

**Notice of References Cited**Application/Control No.  
09/779,416Applicant(s)/Patent Under  
Reexamination  
OSTERGARD, TONIExaminer  
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2612

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**U.S. PATENT DOCUMENTS**

| * |   | Document Number<br>Country Code-Number-Kind Code | Date<br>MM-YYYY | Name | Classification |
|---|---|--|-----------------|------|----------------|
|   | A | US-  |                 |      |                |
|   | B | US-  |                 |      |                |
|   | C | US-  |                 |      |                |
|   | D | US-  |                 |      |                |
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**FOREIGN PATENT DOCUMENTS**

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|---|---|--|-----------------|---------|------|----------------|
|   | N |  |                 |         |      |                |
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|   | R |  |                 |         |      |                |
|   | S |  |                 |         |      |                |
|   | T |  |                 |         |      |                |

**NON-PATENT DOCUMENTS**

| * |   | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)  |
|---|---|--|
|   | U | "Electrostatic Linear Microactuator Mechanism for Focusing a CCD Camera" by Koga, et al., Journal of Lightwave Technology, vol. 17, no. 1, January 1999; p.43-47 |
|   | V |  |
|   | W |  |
|   | X |  |

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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